

INFORMATION DISCLOSURE CITATION

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Applicant(s)

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DS

Carroll, J., et al., "Distributed feedback semiconductor lasers," The Institution of Electrical Engineers, London, United Kingdom, pp. 9-15, (1998)

DS

Kartalopoulos, S., "INTRODUCTION TO DWDM TECHNOLOGY Data in a Rainbow," SPIE Optical Engineering Press, Bellingham, Washington, IEEE Press, pp. 67-68, (1999)

DS

Bann, R., et al., "Micromaching system accommodates large wafers," Laser Focus World, The 2001 Annual Survey of the Laser Marketplace, pp. 189-192, (January 2001)

DS

"Other Optical Components, Distributed feedback semiconductor lasers," Chapter 9, IEE Circuits, Devices and Systems Series 10, Vol. PM52, pp. 131-137

EXAMINER

Dalzid Singh

DATE CONSIDERED

08/12/2004

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.